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PATENT
1794-0141P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Yoshinobu AOYAGI et al. Conf.: 6758
Appl. No.: 09/941,612 Group: 1765
Filed: August 30, 2001 Examiner: M. Song
For: IMPURITY DOPING METHOD FOR SEMICONDUCTOR AS
WELL AS SYSTEM THEREFOR AND SEMICONDUCTOR
MATERIALS PREPARED THEREBY

LETTER TO THE OFFICIAL DRAFTSPERSON

Assistant Commissioner for Patents
Washington, DC 20231

March 10, 2003

Sir:

Pursuant to the Office Action dated November 8, 2002, attached hereto is one (1) sheet of corrected Formal Drawings. Please substitute this corrected drawing for the corresponding Figure 2 currently on file in the above-identified application.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fee required under 37 C.F.R. §§ 1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

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ATTACHMENT